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CONFIRMATION NO. 3898

SERIAL NUMBER	FILING OR 371(c) DATE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.	
10/694,413	10/27/2003 RULE	438	1763	CS99-065CCB	
APPLICANTS Kwok Keung Paul Ho, Singapore, SINGAPORE; Xue Chun Dai, Singapore, SINGAPORE; ** CONTINUING DATA ***** This application is a DIV of 09/442,499 11/18/1999 PAT 6,790,374 <i>gag 12-041</i> ** FOREIGN APPLICATIONS ***** <i>gag 12-041</i> IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 02/27/2004					
Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no 35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after met <i>Allowance</i> Verified and <i>gag 12-041</i> Acknowledged <i>Examiner's Signature</i> Initials		STATE OR COUNTRY SINGAPORE	SHEETS DRAWING 2	TOTAL CLAIMS 17	INDEPENDENT CLAIMS 4
ADDRESS George O. Saile 28 Davis Avenue Poughkeepsie ,NY 12603					
TITLE Plasma etch method for forming plasma etched silicon layer					
FILING FEE RECEIVED 856	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		